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U.S. UTILITY Patent Application

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PATENT NUMBER and
ISSUE DATE

APPL NUM 10003436	FILING DATE 12/06/2001	CLASS 427	SUBCLASS <i>249.7</i>	GAU 1762	EXAMINER <i>chen</i>
**APPLICANTS: Veerasamy Vijayan; Petrmichl Rudolph; <div style="text-align: right;"><i>1762</i></div>					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A CON OF 09/703,709 11/02/2000 WHICH IS A CIP OF 09/657,132 09/07/2000 PAT 6,277,480 WHICH IS A CIP OF 09/627,441 07/28/2000 PAT 6,280,834 AND A CIP OF 09/617,815 07/17/2000 PAT 6,312,808 AND A CIP OF 09/303,548 05/03/1999 PAT 6,261,693 AND A CIP OF 09/442,805 11/18/1999 PAT 6,338,901 AND A CIP OF 09/583,862 06/01/2000 PAT 6,335,086					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials		ATTORNEY DOCKET NO 3651-356			
TITLE : Method of ion beam milling a glass substrate prior to depositing a coating system thereon, and corresponding system for carrying out the same					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheet Drwg.	Fig. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Applicati n Examiner	
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